

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Priority Application Serial No. 09/175,051 *#2/a*
Priority Filing Date October 19, 1998 *11/1/00*
Inventor John T. Moore et al *Sunder*
Assignee Micron Technology, Inc.
Priority Group Art Unit 2822
Priority Examiner M. Guerrero
Attorney's Docket No. MI22-1443
Title: Capacitor Constructions, DRAM Constructions, and Semiconductive
Material Assemblies (As Amended)

PRELIMINARY AMENDMENT

To: Assistant Commissioner for Patents
Washington, D.C. 20231

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AMENDMENTS

In the Title

Replace the title with --Capacitor Constructions, DRAM
Constructions, and Semiconductive Material Assemblies--.

In the Specification

At p. 1, before the "Technical Field" section, insert

RELATED PATENT DATA

This patent resulted from a divisional application of U.S. Patent
Application Serial No. 09/175,051, which was filed on October 19, 1998.

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